

IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED
CENTRAL FAX CENTER

OCT 03 2005

Applicant(s): Yee-Chung Fu
Assignee: Advanced Nano Systems, Inc.
Amended Title: MEMS Scanning Mirror with Trenched Surface and Tapered Comb
Teeth for Reducing Inertia and Deformation
Serial No.: 10/779,952 Filing Date: February 13, 2004
Examiner: Allan R. Wilson Group Art Unit: 2815
Docket No.: ANS-P105

San Jose, California
October 3, 2005

Special Processing Submission
Mail Stop Petition/Mail Stop RCE
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Dear Sir:

In response to the August 18, 2005 Notice of Drawing Inconsistency with Specification,
please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.